

Page 1 of 47

# ESCC QUALIFIED MANUFACTURERS LIST (QML)

| Issue 29 | September 2024 |
|----------|----------------|



Document Custodian: European Space Agency - see https://escies.org



# LEGAL DISCLAIMER AND COPYRIGHT

European Space Agency, Copyright © 2024. All rights reserved.

The European Space Agency disclaims any liability or responsibility, to any person or entity, with respect to any loss or damage caused, or alleged to be caused, directly or indirectly by the use and application of this ESCC publication.

This publication, without prior permission of the European Space Agency and provided it is not used for a commercial purpose, may be:

- copied in whole, in any medium, without alteration or modification.
- copied in part, in any medium, provided that the ESCC document identification, comprising the ESCC symbol, document number and document issue, is removed.



# **DOCUMENTATION CHANGE NOTICE**

(Refer to https://escies.org for ESCC DCR content)

| DCR No. | CHANGE DESCRIPTION   |
|---------|--|
| 1682    | Extension:<br>364B, Flux S/A. (Denmark)<br>The update of the qualified domain includes component types and the range of magnetic<br>components applicable to data transmission.<br>Maximum ratings have been revised with higher values for some parameters. |



PAGE 4

**ISSUE 29** 

# FOREWORD

This document contains a list of qualified manufacturers that have been certified by the European Space Agency for technology flows to the rules of the ESCC system with principle reference to ESCC Basic Specification no. 25400.

The qualified electronic components produced from the technology flows are intended for use in ESA and other spacecraft and associated equipment in accordance with the requirements of the ECSS standard ECSS-Q-ST-60.

Each technology flow qualification and its subsequent maintenance is monitored and overseen by the ESCC executive. ESA certifies the qualification upon receipt of a formal application from the executive stating that all applicable ESCC requirements have been met by the pertinent manufacturer. The qualified status of a technology flow is noted by an entry in this document, a corresponding entry in the European space components information exchange system, ESCIES, and the issue of a certificate to the qualified manufacturer.





# TABLE OF CONTENTS

| 1 PRO | MOTION  | 6  |
|-------|---|----|
| 2 PRO | CURER'S RESPONSIBILITY  | 6  |
| 3 QM  | LORGANISATION   | 6  |
| 3.1   | TECHNOLOGY FLOWS AND PROCESS CAPABILITY APPROVALS (PCA)         | 6  |
| 3.2   | QUALIFIED COMPONENTS  | 6  |
| 3.3   | TYPE DESIGNATION  | 6  |
| 3.4   | COMPONENT CHARACTERISTICS                                       |    |
| 3.5   | MANUFACTURER  | 6  |
| 4 TAB | LE OF QUALIFIED COMPONENT TECHNOLOGY                            | 7  |
| 5 QUA | LIFIED TECHNOLOGY FLOWS   | 8  |
| 5.1   | FILTERS (05)  |    |
| 5.1.1 | KONSBERG SPACE ELECTRONICS, Norway: SAW FILTERS                 |    |
| 5.2   | MICROCIRCUITS (08)  | 13 |
| 5.2.1 | Microchip Technology, France: ATC18RHA                          | 13 |
| 5.2.2 | Microchip Technology, France: ATMX150RHA                        | 17 |
| 5.2.3 | ST Microelectronics, France: ASIC platform C65Space             | 24 |
| 5.2.4 | United Monolithic Semiconductors, France : GaN HEMT             | 29 |
| 5.3   | RESISTORS (10)  |    |
| 5.3.1 | VISHAY S.A. Fance: Chip resistors                               | 34 |
| 5.4   | TRANSFORMERS (08)   | 40 |
| 5.4.1 | Exxelia SAS: Custom magnetics: linear and toroidal technology   | 40 |
| 5.4.2 | Flux A/S: Custom Magnetics (Inductors, Chokes and Transformers) | 42 |



#### 1 PROMOTION

It is permitted to advertise the ESCC qualification status of a component provided such publicity or advertisement does not state or imply that the component is the only qualified one of that particular type, range or family.

# 2 PROCURER'S RESPONSIBILITY

When procuring ESCC qualified components, the procurer is responsible for ensuring that the qualification status is valid and that delivered components fulfil the specified requirements of the applicable ESCC specifications. The procurer is advised to utilise the ESCC non- conformance system, per ESCC Basic Specification No. 22800, in the event that a qualified manufacturer delivers non-conforming components.

# 3 QML ORGANISATION

#### 3.1 TECHNOLOGY FLOWS AND PROCESS CAPABILITY APPROVALS (PCA)

The individual Technology Flows and PCA and are listed in this document by manufacturer in alphabetical order. They may also be found on the ESCIES web site, <a href="https://escies.org">https://escies.org</a>. A Technology Flow Abstract is provided to describe the main features of the qualified Technology Flow.

#### 3.2 QUALIFIED COMPONENTS

Under each technology flow a list of the qualified components is provided.

#### 3.3 <u>TYPE DESIGNATION</u>

Wherever possible the referenced type (style) designations are derived from industrial standards. Where no standardised type designation is applicable the manufacturer's designation is referenced.

#### 3.4 COMPONENT CHARACTERISTICS

The precise characteristics of the qualified component are defined in the referenced ESCC Detail specifications.

#### 3.5 MANUFACTURER

Contact information and plant locations are indicated in the individual Technology Flow listings Contact information may also be found in the ESCC QML section of the ESCIES web site, https://escies.org.



# 4 TABLE OF QUALIFIED COMPONENT TECHNOLOGY

| Components         | Sub-section  | Manufacturers                       | Certificates |
|--------------------|--|-------------------------------------|--------------|
| 05<br>Filters      | SAW  | Kongsberg Defence & Aerospace       | 313F         |
|                    | Digital C-MOS: ATC18RHA                                  | Microchip Technology<br>Nantes      | 357B         |
| 08                 | Digital C-MOS: ATMX150RHA                                | Microchip Technology<br>Nantes      | 359B         |
| Microcircuits      | ASIC platform C65Space                                   | STMicroelectronics                  | 381          |
|                    | GaN HEMT   | United Monolithic<br>Semiconductors | 388          |
| 10<br>Resistors    | Chip   | Vishay SA, Sfernice                 | 287H         |
| 14<br>Transformers | Custom magnetics: linear or toroidal technology          | Exxelia Magnetics                   | 356B         |
| Tansiomers         | Custom Magnetics (Inductors,<br>Chokes and Transformers) | Flux A/S                            | 364A         |



# 5 QUALIFIED TECHNOLOGY FLOWS

The following technology flows are qualified.

#### 5.1 FILTERS (05)

# 5.1.1 KONSBERG DEFENCE & AEROSPACE, Norway: SAW FILTERS

#### 5.1.1.1 Contact Information

| Address                       | ESCC Chief Inspector            |
|-------------------------------|---------------------------------|
| Kongsberg Defence & Aerospace | Mrs Cecilie Berg                |
| Knutsrødveien 7               | Tel: (+47) 3303 2700            |
| N-3189 Horten                 | Fax: (+47) 3303 2800            |
| Norway                        | email: cecilie.berg@norspace.no |

#### 5.1.1.2 Qualification

| Current Qualification<br>Certificate No. | In QML since: | Type Designation   |
|--|---------------|--|
| 313F                                     | •             | SAW filters (transversal band pass/resonator/notch/low loss impedance element) |

#### APPLICABLE ESCC DOCUMENTS:

ESCC Generic Specification No. 3502 ESCC Detail Specification Nos. 3502/002

#### NORSPACE PROCESS IDENTIFICATION DOCUMENTS:

PID534\_9 SAW Device Assembly with flow NORSF-A1 PID630\_9 SAW Crystal Manufacturing with flow NORSF-C1

#### 5.1.1.3 List of Qualified Components

For each design, a detail specification is produced by Kongsberg Space Electronics. Where the SAW component is not proprietary to the customer the detail specification is published in ESCIES as a supporting document. Available detail specifications are found in the table below.

| Detail Specification | Component Type   |
|----------------------|--|
|                      | SAW Filters, Hermetically Sealed, Surface Mount, Frequency<br>Range 10 MHz - 4 GHz |



### 5.1.1.4 Technology Flow Abstract General features

The Technology Flow covers the design, fabrication, assembly, screening, in-process control and testing of the Norspace SAW filters manufactured within the NORSF-C1 and NORSF-A1 processes. The design, crystal manufacturing, assembly, screening and testing is performed in Kongsberg Space Electronics facility at Knudsrødveien 7 in Horten, Norway.

| Technology Flow       | Scope  |
|-----------------------|--|
| Design                | Norspace specification Ko 03.00  |
| Crystal manufacturing | Process flow NORSF-C1 on purchased SAW-grade surface polished wafers.  |
|                       | <u>Wafer materials</u> :<br>Quartz (SiO2), Lithium niobate (LiNbO3), Lithium tantalate<br>(LiTaO3), Langasite (La3Ga5SiO14)<br><u>Wafer dimensions</u> :   |
|                       | 3" diameter 0.5 mm thick<br>3" diameter 1.0 mm thick<br>4" diameter 1.5 mm thick   |
|                       |  |
| Assembly              | Process flow NORSF-A1.<br>Crystal dimensions:<br>from 1.7 mm x 3.1 mm up to 8 mm x 76 mm.  |
|                       | Packages:  |
|                       | -Gold plated Fe-Ni-Co-alloy flat packs.<br>From 4 up to 50 leads with ceramic or glass feedthroughs. External wings<br>for screw attach on some types<br><u>Package dimensions</u> : From 8 mm x 8 mm up to 85 mm x 12 mm.   |
|                       | -Gold plated Fe-Ni-Co-alloy flat packs with Cu-W base, 4 or 6 leads and ceramic feedthroughs.  |
|                       | Package dimensions: From 11 mm x 11 mm up to 7 mm x 21 mm.   |
|                       | -Gold plated ceramic Leadless Chip Carrier (LCC) package, 10 solder pads.<br>Package dimension: 5 mm x 7 mm.   |
| Screening and Test    | Process flow NORSF-A1.   |
|                       | <ul> <li>Incoming inspection</li> <li>In-process inspection</li> <li>100% Wafer probe electrical test</li> <li>100% Visual inspection</li> <li>Final production tests</li> <li>Customer Source Inspection</li> <li>Screening</li> <li>Burn-in and electrical measurements</li> <li>Test procedures</li> <li>External visual inspection</li> <li>Qualification testing</li> </ul> |





#### **Basic Information**

The SAW devices are passive devices and typically require external tuning. Frequency range: From 10 MHz up to 4 GHz.

Max operating temperature range: -30 / +85 °C (maximum), -20 / +70 °C (typical).

Input power: design sensitive.

#### Component Types

- Transversal band pass SAW filters with frequencies up to 4 GHz.
- SAW Resonator filters
- SAW Notch filters
- Impedance element filters with low loss

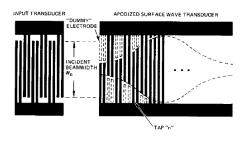
#### 5.1.1.5 Technology Flow definition

#### 1. Design

The design programs are in-house developed procedures and libraries. Each new design is custom made for the application by Kongsberg Space Electronics design engineers. The design centre is in Horten, Norway.

#### Transversal band pass SAW filters

The transversal filters consist of one input transducer and one output transducer, see figure below. The transducers are interdigital transducers formed by a metal pattern on a piezoelectric material (wafer). The transducers can be withdrawal weighted and/or length (apodization) weighted. The detailed weighting functions are calculated in a dedicated filter synthesis software and used as input to the mask layout software. The simulation of the filter response is performed by a dedicated SAW Analysis software.





# **Resonator filters**

The resonator filter consists of input and output transducers as described above. These are normally unweighted. The transducers are backed by reflectors, see figure below. The reflectors are I/4 wide etched grooves or metal fingers. The same software is used for simulation of the transducers and reflectors.

|--|

#### SAW Notch filters

The notch are based on single port resonator elements, so called impedance elements (see below).

Impedance element filters with low loss

Impedance element filters are constructed from one port SAW resonators. The one port SAW resonators consist of one interdigital transducer backed by one reflector on each side, as shown in the figure below.

| Reflector 1 | Transducer 1 | Reflector 2 |
|-------------|--------------|-------------|
|             |              |             |

# 2. Fabrication

The NORSF-C1 process at Kongsberg Space Electronics comprises:

- SAW crystal manufacturing on SAW grade polished single crystal wafers from quartz, LiNbO3, LiTaO3 and La3Ga5SiO14 (langasite)
- Externally purchased SAW wafers
- SAW wafer thickness between 0.5 mm and 1.5 mm
- Photolithography with line widths down to 0.3 m. No upper limit.Metallization performed with Al or Cr/Al. Metal thickness 400 to 10 000 Å.

The process can manufacture SAW elements of band pass, resonator or notch type with centre frequencies in the range 10 MHz to 4 GHz.

# 3. Assembly

Norspace assembly flow NORSF-A1 technology flow covers the following capabilities:





| Package                  | Die Attach | Wire Bond               | Lid Seal        | Leads     |
|--------------------------|------------|-------------------------|-----------------|-----------|
| Flatpack/LCC. Au plated. | Silicone   | Ultrasonic ball- wedge, | Resistance seam | Au plated |
| CuW base/Fe-Ni-Co alloy  | rubber     |                         | sealing.        |           |
| or ceramic with Fe-Ni-Co |            | 25 µm Au wire           | N2 atmosphere.  |           |
| alloy seal ring.         |            |                         |                 |           |
|                          |            |                         |                 |           |

# 4. Test

Measurements are performed using a Vector Network Analyzer (VNA).

All equipment in the electrical test set-up shall have the same characteristic impedance. The Sparameters are measured on the VNA and transferred to a PC for post-processing and analysis. Before testing the VNA and its test cables must be calibrated as specified in the manual for the instrument (full 2-port calibration).

Test vehicles used for qualification: SQF-3800, SLC-4320. Test vehicles used for maintenance: SQF-3800, SLC-3900, or similar devices.

# 5. Radiation

The devices are regarded as radiation insensitive within a small drift in centre frequency and phase allowed for in the design margins.

Radiation testing has been performed successfully up to 50 MRad(Si) for quartz and 1 MRad(Si) for LiNbO3, LiTaO3 and Langasite.

Qualified wafer materials: Quartz, LiNbO3. LiTaO3, Langasite (La3Ga5SiO1)



#### 5.2 MICROCIRCUITS (08)

#### 5.2.1 Microchip Technology, France: ATC18RHA

#### 5.2.1.1 Contact Information

| Address  | ESCC Chief Inspector  |
|--|---|
| Microchip Technology Nantes<br>Route de Gachet<br>44300 Nantes | Ms V. Lepaludier<br>Tel. +33 2 40 18 1633<br>FAX +33 2 40 18 1946 |
| France   | Valerie.Lepaludier@microchip.com                                  |

#### 5.2.1.2 Qualification

| Current<br>Qualification<br>Certificate No. | In QML since: | Type Designation  |
|---|---------------|---|
| 357B  |               | Integrated Circuits, Silicon, Monolithic, CMOS, Cell-Based Array,<br>based on Type ATC18RHA |

#### Remarks:

Certificate 357 supersedes previous certificate 312B Rev1. New certificate reflects significant changes in the supply chain.

An End-Of-Life of the ATC18RHA ASIC offer for new design has been announced by Microchip in January 2021. Detail is available in Microchip Notification CRS20-0158 (information added in QML issue 22, published in March 2021). ATMX150RHA ASICs is to be used as replacement for any new design. Microchip will stop wafer manufacturing launch by December 2021. Microchip commits to maintain the wafer/die stock, based on customer needs. Microchip will continue Flight Models manufacturing from this wafer/die stock.

#### Applicable documents:

ESCC Generic Specification No. 9000; ESCC Detail Specification No. 9202/080

ATC18RHA Process Identification Document PID 0032 Rev F, MMT assembly PID 1G-QM-0105 and HCM columns manufacturing and assembly PID 11 issue F.

#### 5.2.1.3 List of Qualified Components

For each ASIC design an ASIC Sheet is produced by Microchip for use in conjunction with the ESCC Detail Specification No. 9202/080. Where the ASIC is not proprietary to the customer the ASIC sheet is published in ESCIES as a supporting document.

| ASIC Sheet | Component Type |
|------------|----------------|
|            |                |





In the case of ATC18RHA, standard components are also available. These are listed below with their full ESCC Detail Specification:

| Detail<br>Specification | Component Type  |
|-------------------------|---|
| 9512/004                | Integrated Circuits, Silicon, 32-bit SPARC Processor, based on Type AT697F  |
| 9304/165                | Integrated Circuits, Silicon, monolithic, CMOS digital, Field Programmable Gate<br>Array, 280000 gates, based on type ATF280F |
| 9512/005                | Integrated circuits, silicon monolithic, SPARC V8 GNSS controller based on type<br>AT7991                                     |

# 5.2.1.4 Technology Flow Abstract

# **GENERAL FEATURES**

ATC18RHA standard cells family is designed with a 0.18µm radiation hard CMOS technology. This offering is based on 6 metal layers at 1.8V +/-0.15V for the core and 3.3V +/-0.3V for the periphery. This family features arrays with up to 7 Mgates and 544 pads. With its high speed performance, its low supply current and its radiation hard level, the ATC18RHA is suitable for digital applications working in radiation intensive environment.

# **BASIC INFORMATION**

- CMOS technology AT58KRHA
- 40 to 70 kgates per mm<sup>2</sup>
- Periphery power supply 3.3V and 2.5V
- Core power supply 1.8V
- Low supply current :
  - Operating maximum value: 85nW/gate/MHz with a duty cycle at 20%
- I/O Interfaces:
  - Cold sparing
  - High speed LVDS (655 Mps) and LVPECL
  - PCI
  - 544 pads (+ 8 pads power only)
- Embedded memories: Compiled and Synthesized
- EDAC library
- Radiation :
  - No Single Event Latch-Up below a LET Threshold of 80 MeV/mg/cm<sup>2</sup> at high temperature
  - SEU hardened DFF's to 30 MeV/mg/cm2
  - Tested up to 300 krad (Si), Radiation Level is 100 krads (Si).

# COMPONENT TYPES

Device Types as per ESCC Detail Specification 9202/080 and individual custom ESCC ASIC Sheets.



| Die          | Supply Voltage<br>I/O / core | Max<br>programmable<br>I/O's | Case      | Typical<br>Routable gates |
|--------------|------------------------------|------------------------------|-----------|---------------------------|
| ATC18RHA_216 | 2.5V or 3.3V/1.8V            | 216                          | CQFP-F256 | 1M                        |
| ATC18RHA_216 | 2.5V or 3.3V/1.8V            | 216                          | CQFP-F196 | 1M                        |
| ATC18RHA_216 | 2.5V or 3.3V/1.8V            | 216                          | CQFP-F160 | 1M                        |
| AT697F       | 3.3V/1.8V                    | -                            | CQFP-F256 | 0.85M                     |
| ATC18RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CQFP-F352 | 2.2M                      |
| ATC18RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CQFP-F256 | 2.2M                      |
| ATC18RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CQFP-F196 | 2.2M                      |
| ATC18RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CQFP-F160 | 2.2M                      |
| ATC18RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CLGA-349  | 2.2M                      |
| ATC18RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CCGA-349  | 2.2M                      |
| ATC18RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CQFP-T352 | 3.5M                      |
| ATC18RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CQFP-T256 | 3.5M                      |
| ATC18RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CLGA-472  | 3.5M                      |
| ATC18RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CLGA-349  | 3.5M                      |
| ATC18RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CCGA-472  | 3.5M                      |
| ATC18RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CCGA-349  | 3.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CQFP-T352 | 5.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CQFP-F256 | 5.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CLGA-625  | 5.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CLGA-472  | 5.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CLGA-349  | 5.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CCGA-625  | 5.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CCGA-472  | 5.5M                      |
| ATC18RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CCGA-349  | 5.5M                      |
| AT7991       | 3.3V/1.8V                    | -                            | CQFP-352  | 7.6M                      |
| ATC18RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CLGA-625  | 7M                        |
| ATC18RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CCGA-625  | 7M                        |

# 5.2.1.5 Technology Flow Definition

The Technology Flow Definition domain covers the design, fabrication, assembly and testing of the ATC18RHA standard cells family.

#### 1. Design

The design manual and the ASIC library data books cover the design in the Microchip Technology Nantes associated Design Centers (Nantes-France, Milan-Italy, Garching-Germany and Winnersh-UK).



| _ | ATC18RHA Design manual                 | ATD-DE-GR-R0212 |
|---|--|-----------------|
| _ | ATC18RHA TOS manual                    | ATD-DE-GR-R0324 |
| _ | ATC18RHA Buffers library databook      | ATD-TS-LR-R0252 |
| - | ATC18RHA Cells library databook        | ATD-TS-LR-R0251 |
| _ | ATC18RHA Memory cells library databook | ATD-TS-LR-R0254 |
| - | ATC18RHA specific library databook     | ATD-TS-LR-R0253 |
|   |  |                 |

All ASIC designs will be performed by the customer at the customer site, with Microchip supported tools (front end).

No new design is proposed on this ASIC technology, replaced by the ATMX150RHA.

# 2. Fabrication

The ATC58KRHA, processed in UMC Taiwan, is a 0.18µm CMOS, 6 metal, Ti, TiN and AlCu process.

From 2021 December, wafer fabrication shall not be maintained. Flight models shall be manufactured from wafer in stock.

# 3. Assembly

The assembly of ATC18RHA devices is performed in MMT, Thailand, with the following capabilities:

- Die attach Cyanate Ester (JM7000)
- Wire bond Ultrasonic Wedge, 25 and 32 µm Al
- Lid sealing Brazed with Au/Sn alloy or seam welded
- Leads/pads Gold plated (CQFP and CLGA)

The assembly of columns is performed in SERMA HCM, La Rochelle, with the following capabilities:

• Columns 85Pb15Sn with Tinned Copper ribbon, 0.38 mm diameter

# 4. Control and Test

The control and test of ATC18RHA devices is performed in Microchip technology Nantes. It includes Lot Acceptance, Test Flows and Test Procedures, Qualification Test and Reliability Monitoring, Screening and associated electrical tests and inspections.

# 5. TCVs and SEC

The die ATC18RHA\_324 is used for both test vehicles. All details are described in the ATC18RHA test chip specification, reference ADF-DE-R0561-CUP.

# V56 TEST VEHICLE

The V56 is a buffer test vehicle representative of the range of buffers available for performance testing in the CQFP 256 package. It contains standard IO33 buffers, specific IO33 buffers (LVDS, PCI), a PLL, a set of ring oscillators made of different library cells and a set of interconnect lines.

# V40 (5 METAL LAYERS) OR V52 (6 METAL LAYERS) TEST VEHICLE – TECHNOLOGY SEC

The V40/V52 SEC is developed for performance and radiation testing in the CQFP 256 package. It contains a set of memory blocks (compiled memories with and without EDACs and synthesized (on gates) memories made with standard and hardened latches), shift registers chains and a PLL.



#### 6. Radiation Characteristics

The AT58KRHA family has been developed to fulfil the following characteristics:

- No Single Event Latch-up below a LET Threshold of 80MeV/mg/cm2 at high temperature
- Availability of SEU hardened cells
- Total dose capability over 100 krads(Si)
- 5.2.1.6 Manufacturing sites

#### **DESIGN:**

Microchip Technology Nantes, BP70602, 44306 Nantes Cedex 3, France

#### WAFER FABRICATION:

UMC Fab 8S, Hsin-Chu, Taiwan

#### **DIE ASSEMBLY:**

MMT, Microchip Technology (Thailand) Co., Ltd. 17/2 Moo 18 Suwintawong Road, Saladang, Bangnumpriew Chachoengsao, Thailand 24000

#### CCGA COLUMN ASSEMBLY:

HCM SYSTREL, 34 Av. Joliot Curie, ZI Perigny, 17185 Perigny Cedex, France

#### CONTROL AND TEST:

Microchip Technology Nantes, BP70602, 44306 Nantes Cedex 3, France

#### 5.2.2 Microchip Technology, France: ATMX150RHA

#### 5.2.2.1 Contact Information

| Address                     | ESCC Chief Inspector             |
|-----------------------------|----------------------------------|
| Microchip Technology Nantes | Ms V. Lepaludier                 |
| Route de Gachet             | Tel. +33 2 40 18 1633            |
| 44300 Nantes                | FAX +33 2 40 18 1946             |
| France                      | Valerie.Lepaludier@microchip.com |
|                             |                                  |

#### 5.2.2.2 Qualification

| Current<br>Qualification<br>Certificate No. | In QML since: | Type Designation   |
|---|---------------|--|
| 359B  |               | Integrated Circuits, Silicon, Monolithic, CMOS, Cell-Based Array, based on ATMX150RHA ASIC family. |

#### Remark:

Certificate 359 supersedes previous certificate 342 Rev1. New certificate reflects significant changes in the supply chain.



# APPLICABLE DOCUMENTS:

ESCC Generic Specification No. 9000; ESCC Detail Specification No. 9202/083

Microchip Process Identification Document PID 37 Rev F, MMT PID 1G-QM-0105, HCM columns manufacturing and assembly PID 11 issue F.

#### 5.2.2.3 List of Qualified Components

For each ASIC design an ASIC Sheet is produced by Microchip for use in conjunction with the ESCC Detail Specification No. 9202/083. Where the ASIC is not proprietary to the customer the ASIC sheet is published in ESCIES as a supporting document.

| ASIC Sheet | Component Type |
|------------|----------------|
|            |                |

#### 5.2.2.4 Technology Flow Abstract

#### **GENERAL FEATURES**

The ATMX150RHA is a mixed-signal ASIC offer providing high-performance and high-density solutions for space applications. The ATMX150RHA standard cells family is designed with a 0.15µm radiation-hardened CMOS technology. This offer is based on a 5 metal layers with an optional 6th thick metal layer technology, dedicated for large ASIC's to avoid voltage drop issues. The core is supplied at 1.8V +/-0.15V and the periphery at 3.3V +/-0.3V or 2.5V +/- 0.2V. This family features arrays with up to 22 Mgates and more than 700 pads. With its high-speed performance, its low supply current and its radiation hardening level, the ATMX150RHA is suitable for digital applications working in radiation intensive environment.

#### **BASIC INFORMATION**

- CMOS technology AT77K9RHA
- 40 to 70 kgates per mm<sup>2</sup>
- Periphery power supply 3.3V and 2.5V
- Core power supply 1.8V
- Low supply current: Operating maximum value: 8.8 nA/gate/MHz with a duty cycle at 20%
- I/O Interfaces:
  - o Cold sparing
  - High speed LVDS (655 Mps) and LVPECL
  - o PCI
- 704 pads (+ 8 pads power only)
- Compiled memory cells (ROM, SRAM, DPRAM, register files)
- Pre-qualified IP's
  - o a regulator 1.8V 200mA Linear Voltage Regulator REG200RHA
  - o a 8-channels analog input multiplexer MUX8RHA
  - o a PLL 40 to 450 MHz PLL400MRHA
  - o a RC Oscillator4/8/10/12 MHz OSCRC10MRHA
  - a bandgap 1.215V reference BG1V2RHA
- Radiation:
  - No Single Event Latchup to a LET threshold of 67.7 MeV.cm<sup>2</sup>/mg, and up to 78. 2 MeV.cm<sup>2</sup>/mg, 30°-tilted at high temperature.
  - SEU Hardened DFF's to 30 MeV/mg/ cm2
  - Tested up to 300 kRads(Si).



<u>COMPONENT TYPES</u> Device Types as per ESCC Detail Specification 9202/083 and individual custom ESCC ASIC Sheets:

| Die            | Supply Voltage<br>I/O / core | Max<br>programmable<br>I/O's | Case     | Typical Routable<br>gates |
|----------------|------------------------------|------------------------------|----------|---------------------------|
| ATMX150RHA_216 | 2.5V or 3.3V/1.8V            | 216                          | CQFP-256 | 1M                        |
| ATMX150RHA_216 | 2.5V or 3.3V/1.8V            | 216                          | CQFP-132 | 1M                        |
| ATMX150RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CQFP-352 | 2.2M                      |
| ATMX150RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CQFP-256 | 2.2M                      |
| ATMX150RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CQFP-132 | 2.2M                      |
| ATMX150RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CLGA-472 | 2.2M                      |
| ATMX150RHA_324 | 2.5V or 3.3V/1.8V            | 324                          | CCGA-472 | 2.2M                      |
| ATMX150RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CQFP-352 | 3.5M                      |
| ATMX150RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CQFP-256 | 3.5M                      |
| ATMX150RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CLGA-625 | 3.5M                      |
| ATMX150RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CLGA-472 | 3.5M                      |
| ATMX150RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CCGA-625 | 3.5M                      |
| ATMX150RHA_404 | 2.5V or 3.3V/1.8V            | 404                          | CCGA-472 | 3.5M                      |
| ATMX150RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CQFP-352 | 5.5M                      |
| ATMX150RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CQFP-256 | 5.5M                      |
| ATMX150RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CLGA-625 | 5.5M                      |





| Die            | Supply Voltage<br>I/O / core | Max<br>programmable<br>I/O's | Case     | Typical Routable<br>gates |
|----------------|------------------------------|------------------------------|----------|---------------------------|
| ATMX150RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CLGA-472 | 5.5M                      |
| ATMX150RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CCGA-625 | 5.5M                      |
| ATMX150RHA_504 | 2.5V or 3.3V/1.8V            | 504                          | CCGA-472 | 5.5M                      |
| ATMX150RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CQFP-352 | 6.5M                      |
| ATMX150RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CQFP-256 | 6.5M                      |
| ATMX150RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CLGA-625 | 6.5M                      |
| ATMX150RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CLGA-472 | 6.5M                      |
| ATMX150RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CCGA-625 | 6.5M                      |
| ATMX150RHA_544 | 2.5V or 3.3V/1.8V            | 544                          | CCGA-472 | 6.5M                      |
| ATMX150RHA_604 | 2.5V or 3.3V/1.8V            | 604                          | CQFP-352 | 7.5M                      |
| ATMX150RHA_604 | 2.5V or 3.3V/1.8V            | 604                          | CLGA-896 | 7.5M                      |
| ATMX150RHA_604 | 2.5V or 3.3V/1.8V            | 604                          | CLGA-625 | 7.5M                      |
| ATMX150RHA_604 | 2.5V or 3.3V/1.8V            | 604                          | CCGA-896 | 7.5M                      |
| ATMX150RHA_604 | 2.5V or 3.3V/1.8V            | 604                          | CCGA-625 | 7.5M                      |
| ATMX150RHA_644 | 2.5V or 3.3V/1.8V            | 644                          | CQFP-352 | 8.7M                      |
| ATMX150RHA_644 | 2.5V or 3.3V/1.8V            | 644                          | CLGA-896 | 8.7M                      |
| ATMX150RHA_644 | 2.5V or 3.3V/1.8V            | 644                          | CLGA-625 | 8.7M                      |
| ATMX150RHA_644 | 2.5V or 3.3V/1.8V            | 644                          | CCGA-896 | 8.7M                      |





| Die            | Supply Voltage<br>I/O / core | Max<br>programmable<br>I/O's | Case     | Typical Routable<br>gates |
|----------------|------------------------------|------------------------------|----------|---------------------------|
| ATMX150RHA_644 | 2.5V or 3.3V/1.8V            | 644                          | CCGA-625 | 8.7M                      |
| ATMX150RHA_704 | 2.5V or 3.3V/1.8V            | 704                          | CQFP-352 | 10.4M                     |
| ATMX150RHA_704 | 2.5V or 3.3V/1.8V            | 704                          | CLGA-896 | 10.4M                     |
| ATMX150RHA_704 | 2.5V or 3.3V/1.8V            | 704                          | CLGA-625 | 10.4M                     |
| ATMX150RHA_704 | 2.5V or 3.3V/1.8V            | 704                          | CCGA-896 | 10.4M                     |
| ATMX150RHA_704 | 2.5V or 3.3V/1.8V            | 704                          | CCGA-625 | 10.4M                     |



# 5.2.2.5 Technology Flow Definition

The Technology Flow covers the design, fabrication, assembly and testing of the ATMX150RHA standard cells ASIC family.

# 1. Design

The design manual and the ASIC library data books cover the design in the Microchip Technology Nantes associated Design Centers (Nantes and Rousset-France, Milan-Italy, Garching-Germany and Winnersh-UK).

| ATMX150RHA design manual                         | 2012_EC_054_ELE |
|--|-----------------|
| ATMX150RHA TOS (Test Oriented Simulation) Manual | ATD-DE-GR-R0324 |
| ATMX150RHA supply & ESD buffer databook          | 2012_EC_055_ELE |
| ATMX150RHA buffer 3.3V databook                  | 2012_EC_051_ELE |
| ATMX150RHA buffer 2.5V databook                  | 2012_EC_052_ELE |
| ATMX150RHA Cells library databook                | 2012_EC_050_ELE |
| ATMX150RHA memory cells library databook         | 2012_EC_053_ELE |
| ATMX150RHA power grid verification flow          | 2014_EC_131-ELE |

All ASIC designs will be performed by customer at customer site, with Microchip supported tools (front end).

#### 2. Fabrication

The AT77K9RHA, processed in UMC Taiwan, is a 0.15 µm CMOS, 5-metal with an optional 6th thick metal, Ti, TiN and AlCu process.

#### 3. Assembly

The assembly of ATMX150RHA devices is performed in MMT, Thailand, with the following capabilities:

- Die attach Cyanate Ester (JM7000)
- Wire bond Ultrasonic Wedge, 25 and 32 µm Al
- Lid sealing Brazed with Au/Sn alloy or seam welded
- Leads/pads Gold plated (CQFP and CLGA)

The assembly of columns on CLGA is performed in SERMA HCM, La Rochelle, with the following capabilities:

• Columns 85Pb15Sn with Tinned Copper ribbon, 0.38 mm diameter

#### 4. Control & Test

The control and test of ATMX150RHA devices is performed in Microchip Technology Nantes.

It includes Lot Acceptance, Test Flows and Test Procedures, Qualification Test and Reliability Monitoring, Screening and associated electrical tests and inspections.





# 5. TCVs and SEC

#### 002NY TEST VEHICLE

The 002NY is a buffer test vehicle representative of the range of buffers available for performance testing in the CQFP-352 package. It contains standard IO33 buffers, specific IO33 buffers (LVDS, PCI), a PLL, a set of ring oscillators made of different library cells and a set of interconnect lines.

# 002PF TEST VEHICLE

The 002PF is a test vehicle representative of the IP blocks available for performance testing in the CQFP-256 package. It contains the REG200RHA, the OSCR10MRHA, the MUX8RHA, the BG1V2RHA and the PLL400MRHA.

#### 002OP TEST VEHICLE - TECHNOLOGY SEC

The 002OP SEC is developed for radiation testing, process stability, reliability monitoring and performance characterization, it is assembled in the CQFP-352 package. It contains a set of memory blocks (compiled memories with and without EDACs), shift registers chains, high speed LVDS, PCI buffers and a PLL. It uses the thick-metal layer option.

#### 002MS TEST VEHICLE - TECHNOLOGY SEC

The 002MS has the same characteristics than the 002OP, without the thick-metal layer option. 002MS will be embarked on MPW (Multi-Project Wafer) instead of 002OP when MPW ASIC's do not need thick metal layer. When so, 002MS shall be used for reliability quarterly monitoring.

# 6. Radiation Characteristics

The AT77K9RHA technology has been developed to fulfil the following characteristics:

- Total dose capability over 100 kRads (Si).
- No Single Event Latchup to a LET threshold of 67.7 MeV.cm<sup>2</sup>/mg, and up to 78.2 MeV.cm<sup>2</sup>/mg, 30° tilted at high temperature.
- Availability of SEU hardened cells.
- 5.2.2.6 Manufacturing sites

#### **DESIGN:**

Microchip Technology Nantes, BP70602, 44306 Nantes Cedex 3, France

#### WAFER FABRICATION:

UMC Fab 8C, Hsin-Chu, Taiwan

#### DIE ASSEMBLY:

MMT, Microchip Technology (Thailand) Co., Ltd. 17/2 Moo 18 Suwintawong Road, Saladang, Bangnumpriew Chachoengsao, Thailand 24000

#### CCGA COLUMN ASSEMBLY:

SERMA Microelectronics, 34 Av. Joliot Curie, 17185 Perigny Cedex, France

#### CONTROL AND TEST:

Microchip Technology Nantes, BP70602, 44306 Nantes Cedex 3, France



# 5.2.3 ST Microelectronics, France: ASIC platform C65Space

#### 5.2.3.1 Contact Information

| Address | ESCC Chief Inspector  |
|---------|---|
|         | Ms Sylvie PERON<br>Tel. +33 2 99 26 4800 ext: 4839<br>sylvie.peron@st.com<br>ASICs QA Project Manager |
| France  | M. Jean-Noël LETRILLARD<br>Tel. +33 2 99 26 4800 ext : 4937<br>jean-noel.letrillard@st.com            |

#### 5.2.3.2 Qualification

| Current<br>Qualification<br>Certificate No. | In QML since: | Type Designation  |
|---|---------------|---|
| 381   |               | Integrated Circuits, Silicon, Monolithic, CMOS Radiation Hardened<br>65nm ASIC Platform, based on type C65Space |

#### Applicable documents:

ESCC Generic Specification No. 9000; ESCC Detail Specification No. 9202/086

STMicroelectronics Process Identification Documents:

- 8097046: GENERIC PID Ref. ST.01.2008
- DM00508779: PID FOR ASICs C65S WB and FC
- DM00508782: PID ASICs C65Space WB and FC Die Layout

#### 5.2.3.3 List of Qualified Components

| Component<br>Number | Detail<br>Specification | Generic part<br>number | Circuit function                                | FPGA Matrix | Package  |
|---------------------|-------------------------|------------------------|---|-------------|----------|
| 930401001A          |                         |                        | 3M System gate field<br>programmable gate array | NX1H35AS    | CQFP-352 |
| 930401002A          | 9304/010                |                        | 3M System gate field<br>programmable gate array | NX1H35AS    | CLGA-625 |



# 5.2.3.4 Technology Flow Abstract

# **GENERAL FEATURES**

The CMOS 65nm SPACE is a silicon technology node, 8 metal layers. It provides a logic capacity with additional DSPs, a 400 Mbs SpaceWire physical interface and also a DDR 2/3 physical interface. Benefiting from an advanced underlying technology, the NG-Medium provides high performances in terms of frequency and consumption. It is also reprogrammable without any limits.

- Power supply:
  - Core: 1.2V±10%.
  - IOS: 1.5V±10% or 1.8V±10% or 2.5V±10% or 3.3V±10%.
- Performance:
  - o 250MHz Logic.
  - o 333MHz DSP.
  - 800Mbps I/O.
- Temperature :
  - -55°C to +125°C.

#### **BASIC INFORMATION**

#### Main features

- 65 nm ST-SPACE process technology.
- 4-Input Look-up tables.
- Lut expender to support up to 16 bits boolean functions.
- High performance carry chains.
- Advanced interconnect network to support random logic and coarse grain block functions.
- DSP Blocks for complex arithmetic operations.
- User memories with variable width and depth.
- Configuration modes: JTAG, Parallel 8 bits, Parallel 16 bits, Serial dump bus, Space Wire
- Integrated Space Wire interface available for user applications.
- Dedicated lowskew distribution network for clock, reset and load enable signals.
- On-chip thermal monitoring capability.

#### Input/Output features

- Multiple I/O powering support from 1.5V to 3.3V
- Cold sparing support.
- Programmable output drive to support multiple industry standards.
- Embedded logic to support DDR2 and DDR3.
- 800 Mbps I/O support.
- LVDS compatible mode.
- All pins support 2000V of ESD-HBM.
- Embedded logic to support Space Wire Data Strobe encoding.



- Programmable delay lines on all pins.
- Programmable resistive termination.

# COMPONENT TYPES

Device Types as per ESCC Detail Specification 9202/086 and individual custom ESCC ASIC Sheets:

| Part number    | Part Type | Package  | Temperature range |
|----------------|-----------|----------|-------------------|
| 920208601A#### | C65SPACE  | CQFP-352 | -55°C to +125°C   |
| 920208602A#### | C65SPACE  | CLGA-625 | -55°C to +125°C   |

#### 5.2.3.5 Technology Flow Definition

The Technology Flow Definition domain covers the design, fabrication, assembly and testing of packaged products using ST C65Space silicon technology node and ST assembly line technology capabilities in CQFP352 and CLGA625 packages family.

#### 1. Design

The following features are based on ST ESCC evaluated libraries from C65SPACE Design Environment:

- DSPs,
- DPRAMs & SPREGs memories,
- Input / Output in I/O Banks (except for the pas itself, which keeps original pad structure but receives Custom Design Add On featuring)
- Bitstream manager,
- PLLs (1201),
- Waveform generators,
- SapceWire Interface (including LVDS pads).

Other features designed by NanoXplore are full in compliant with ST C65Space design rules.

The NG-MEDIUM FPGA is based on NanoXplore patented interconnect architecture offering the highest logic density as well as high efficiency mapping. Application mapping is supported by NanoXplore tools based on proprietary algorithms tailored to the interconnect topology.

The device is composed of a central fabric embedding the programmable logic, RAM and DSP blocks, and peripheral I/O buffers. The fabric is covered with a grid of high level functional blocks interleaved with interconnect structures providing routing resources to realize the connections within the fabric and to the peripheral I/O buffers. The programmable logic resources are arranged in a hierarchical structure called a TILE with a specific local interconnect network. The I/O buffers are arranged into multiple banks. Each bank has its own I/O buffer supply voltage.



# 2. Fabrication

The wafer manufacturing is performed in ST Crolles 300mm fab using the new C65SPACE technology silicon node developed in ST Crolles 300mm and successfully qualified by ST in September 2014.

The main characteristics of the silicon die are described below:

Mask Levels: 41. Masks Levels of Metallization: 8 (7 Layers in Cu + 1 Layer Ta/TaN/AlCu). Die size: 15.3\*10.96 mm<sup>2</sup>. Die Pad Pitch: 70μm min. Die Pad Opening: 44\*108 μm<sup>2</sup>. Die Pads Numbers: 374 non-staggered. Die Finish Front Side (passivation): PSG + Nitride. Die Finish Back Side: Raw Silicon. An additional step of OPM (Over Pad Metallization) deposition is performed at a third party subcontractor ChipBond (TW), under ST quality control. OPM : TiW/Au (Au= 3.5μm±1μm) OPM Pad size : 54\*165 μm<sup>2</sup>

#### 3. Assembly

#### Process

The assembly process of the C65 Space devices is set-up in the historical ST Space certified plant in Rennes, France using the main following process capabilities:

Die Attach Medium: "Cyanate Ester" JM7000 Wire Bonding technology: Ultrasonic Gold Ball-Bonding. Wire: 0.8 mils (20µm) Gold 4N Bonding Decks & Bonding wire number:

|                       | CQFP352 | CLGA625 |
|-----------------------|---------|---------|
| Bonding decks N#      | 2       | 2       |
| Bonding wires N#      | 448     | 630     |
| Bond Wires on Deck #1 | 223     | 323     |
| Bond Wires on Deck #2 | 225     | 307     |

#### Package 1

Ceramic Quad Flat Package with 352 leads (CQFP352) with Ceramic Tie Bar Dimensions: 75\*75\*3.51 mm3. Cavity Size: 17\*12.66 mm<sup>2</sup> Cavity Volume: 320 mm3. Lid Material: Kovar with Plating Layers (Ni/Au) Lid Size: 23.62\*19.30 mm<sup>2</sup> Lead finishing: Au Plated

#### Package 2



Ceramic Land Grid Array with 625 leads (CLGA625) Dimensions: 29\*29\*4.02 mm3. Cavity Size: 17.00\*12.66 mm<sup>2</sup> Lead sealing: Eutectic brazing with Au/Sn alloy preform Cavity Volume: 252.9 mm3. Lid Material: Kovar with Plating Layers (Ni/Au) Lid Size: 20.47\*20.47 mm<sup>2</sup> Lead finishing: Au Plated **4.** Control and Test

The control & test of C65 Space devices are performed in both ST Grenoble plant, France for electrical testing and accelerated ageing (reliability screening) and Rennes, France for all other space related tests or at subcontracted third parties under Rennes Quality monitoring and control.

All these space related manufacturing operations are performed under the supervision and control of the ST ESCC Chief Inspector, located in our basic space plant, Rennes.

# 5. TCVs and SEC

TCV program has been carried out to address intrinsic failure mechanisms of the C65Space technology. NG-Medium encapsulated in CQFP352 and CLGA625 are used as SECs to conduct all the requested evaluation and qualification tests.

# 6. Radiation Characteristics

The ST C65SPACE technology has been developed to fulfil the following characteristics:

- SEL immune up to LET > 60MeV.cm2/mg.
- TID tolerance = 300 krad(Si).

#### 5.2.3.6 Manufacturing sites

#### **DESIGN:**

NanoXplore 1 avenue de la Cristallerie, 92310 Sèvres, France

#### WAFER FABRICATION:

ST Crolles 300 - 850 rue Jean Monnet 38926 Crolles, France

#### ASSEMBLY:

ST Rennes – 3 rue de Suisse 35200 Rennes, France. Basic Plant

#### CONTROL AND TEST:

ST Grenoble - 12 rue Jules Horowitz, B.P. 217 38019 Grenoble, France ST Rennes – 3 rue de Suisse 35200 Rennes, France. Basic Plant



# 5.2.4 United Monolithic Semiconductors, France : GaN HEMT

# 5.2.4.1 Contact Information

| Address   | ESCC Chief Inspector   |
|---|--|
| United Monolithic Semiconductors<br>Batiment Charmille<br>Mosaic parc Courtaboeuf<br>10 avenue du Quebec<br>91140 Villebon sur Yvette | Mr B. LAMBERT<br>+33 6 45 74 51 75<br>+33 1 69 86 32 88<br>Benoit.Lambert@ums-rf.com |

# 5.2.4.2 Qualification

| Current Qualification<br>Certificate No. | In QML since: | Type Designation  |
|--|---------------|---|
| 388                                      |               | Transistors, Microwave, GaN HEMT Unmatched in Metal Ceramic<br>Package CHKxxxx-SYx Product Family |

#### 5.2.4.3 List of Qualified Components

| Variant<br>number | Detail<br>Specification | Generic part<br>number | Component type | Package                       |
|-------------------|-------------------------|------------------------|----------------|-------------------------------|
| 01                | 5614/009                | CHK8101-SYC            | 15W @ 1.7GHz   | Ceramic-Metal, Flanged,Type C |
| 02                | 5614/009                | CHK8201-SYA            | 50W @ 1.7GHz   | Ceramic-Metal, Flanged,Type A |
| 03                | 5614/009                | CHKA012bSYA            | 130W @ 1.7GHz  | Ceramic-Metal, Flanged,Type A |

#### 5.2.4.4 Technology Flow Abstract

CHKxxxx-SYx Product Family is based on the UMS GH50-20 GaN power bar technology. Power bars are assembled using AuSn eutectic soldering in a highly dissipated ceramic-metal Flanged packaged. To assure RF stability of each component type, an RF absorber is used in the package cavity. All manufacturing and test production is performed in accordance to the ESCC/5010.



|                              | CAPABILITY APPROVAL DOMAIN  |                             |  |  |
|------------------------------|-----------------------------|-----------------------------|--|--|
|                              | RIC1 (Product: CHK8101-SYC) | RIC3 (Product: CHKA012bSYA) |  |  |
| GaN DIE PROCESS              |                             |                             |  |  |
| Die overview                 |                             |                             |  |  |
| Manufacturer                 | UMS – Ulm – Germany         |                             |  |  |
| Power bar dies<br>technology | UMS 4GH50-20                |                             |  |  |
| Gate pitches                 | 70µm                        |                             |  |  |
| Unitary gate finger<br>width | 250µm & 400                 | μm                          |  |  |
| Finger gates per block       | 8                           |                             |  |  |
| Number of blocks             | 2,4,8                       |                             |  |  |
| Max operating Freq.<br>(GHz) | 6 GHz                       |                             |  |  |
| PACKAGE TECHNOL              | DGY                         |                             |  |  |
| Package overview             |                             |                             |  |  |
| Package manufacturer         | Kyocera – Gamo – Japan      |                             |  |  |
| UMS Package<br>reference     | SYC                         | SYA                         |  |  |
| UMS SAP Material N°          | 47003170                    | 47002520                    |  |  |
| Sealing                      | Seam-welding process        | 1                           |  |  |





| Lead                                 | 2   | 4                   |  |  |  |
|--------------------------------------|---|---------------------|--|--|--|
| Base plate length (mm)               | 17.5 20   |                     |  |  |  |
| Base plate width (mm)                | 6.7   |                     |  |  |  |
| Lid for Package:<br>Manufacturer     | Hi-REL Group  |                     |  |  |  |
| UMS Drawing<br>Document N°           | 61504640 61503116 last version  |                     |  |  |  |
| <u>RF Absorber :</u><br>Manufacturer | DEMGY   |                     |  |  |  |
| UMS Material N°                      | 47003186  | 47003186            |  |  |  |
| ASSEMBLY TECHNOL                     | OGY   |                     |  |  |  |
| Assembly<br>subcontractor            | RHe Microsystems GmbH – Radeberg – Germany  |                     |  |  |  |
| Preform characteristics              | Material: Eutectic Au80Sn20 (Liquidis:278°C),   |                     |  |  |  |
| Sealing process                      | Hermetical seam sealed  |                     |  |  |  |
|                                      | Stabilization bake - 24h @ 150°C / MIL-STD-750 method 1032  |                     |  |  |  |
| Assembly screening                   | Temp. Cycling - 20 cycles -55/+150°C / MIL-STD-750 method 1051  |                     |  |  |  |
| (100%)                               | PIND test - MIL-STD-750 method 2052   |                     |  |  |  |
| ( )                                  | X-ray - Wire bonding inspection /   | MIL-STD-883 2009.12 |  |  |  |
|                                      | Leak test - MIL-STD-883-1014.15 Cond A2   |                     |  |  |  |
| ELECTRICAL SCREEN                    | IING FLOW   |                     |  |  |  |
| Manufacturer                         | UMS – Villebon – France   |                     |  |  |  |
| Burn In 1                            | 10hrs - Tamb=+125°C; VD=+50V; VG=-7V  |                     |  |  |  |
| Electrical Stabilization (100%)      | 10hrs - Tj=200°C; VD=+50V; VG=cst (RIC1:ID=256mA / RIC3:ID=1.25A)   |                     |  |  |  |
| Burn-In 2                            | 240hrs - Tj=200°C; VD=+50V; VG=cst (RIC1:ID=256mA /<br>RIC3:ID=1.25A)   |                     |  |  |  |
| (100%)                               | RF characterization / Acceptance criteria based on specification and on parameter drift (before/after burn-in) / Pulsed or CW |                     |  |  |  |



| FINAL PRODUCT     |             |             |
|-------------------|-------------|-------------|
| Product overview  |             |             |
| Typical RF-power  |             |             |
| @1.3GHz           | >15W        | >100W       |
| (Vds=50V,         |             |             |
| Idq=25mA/mm)      |             |             |
| Product reference | CHK8101-SYC | CHKA012bSYA |

#### Radiation characteristics

Displacement Damage (DD) tests show no influence of proton irradiation on the electrical performance up to a tested fluence of 10<sup>12</sup> p/cm2.

Total lonizing Dose (TID) tests show no influence of Co60 irradiation up to a final tested dose of 274 krad (in GaN).

Single Event Burn-out (SEB) levels for gate and drain RF voltage excursions for transistors operating in class AB, such as described in next table.

| Characteristics                      | Symbols              | Safe Operating Area | Units | Remarks  |
|--------------------------------------|----------------------|---------------------|-------|--|
| Drain-Source Voltage<br>RF-Excursion | $V_{DS\_peak}$       | ≤ 125               | V     | Xe ions (LET-<br>Si = 62.5keV/µm)<br>Fluence = 1.E+07 ions/cm2 |
| Gate-Source Voltage<br>RF-Excursion  | $V_{GS\_peak}$       | ≥ -6                | V     |  |
| Drain-Source Voltage<br>RF-Excursion | V <sub>DS_peak</sub> | ≤ 125               | V     | Rh ions (LET-<br>Si = 46.1keV/µm)<br>Fluence = 1.E+07 ions/cm2 |
| Gate-Source Voltage<br>RF-Excursion  | $V_{GS_peak}$        | ≥ -9                | V     |  |



#### In vacuum environment characteristics

Corona/Multipaction free operation test campaign was performed. No failure occurred up-to the maximum levels that it was possible to evaluate and which are provided in table here after.

| Characteristics                       | Symbols              | Safe Operating<br>Area | Units | Remarks                                 |
|---------------------------------------|----------------------|------------------------|-------|---|
| Drain-Source Voltage RF-<br>Excursion | VDS_peak             | ≤ 133                  | V     | Multipaction<br>Phenomena<br>See Note 1 |
| Drain-Source Voltage RF-<br>Excursion | V <sub>DS_peak</sub> | ≤ 138                  | V     | Corona Phenomena<br>See Note 2          |

#### NOTES:

- 1) Multipaction test conditions: Pressure < 1.5 10<sup>-5</sup> mbar, frequency = 1.25GHz, Test board temperature from -30°C to 70°C
- 2) Corona test conditions: Pressure from 900mbar to <1.5 10<sup>-5</sup> mbar, frequency = 1.25GHz, Test board temperature from -30°C to 70°C

#### 5.2.4.5 Manufacturing sites

WAFER FABRICATION: UMS Gmbh Wilhelm Runge Strasse 11 D-089081 Ulm Germany

DIE ASSEMBLY:

RHe Microsystems Gmbh Heidestrass 70 01454 Radeberg Germany

CONTROL AND TEST: UMS SAS 10 avenue du Quebec 91140 Villebon sur Yvette France





# 5.3 RESISTORS (10)

# 5.3.1 VISHAY S.A. Fance: Chip resistors

#### 5.3.1.1 Contact Information

| Address   | ESCC Chief Inspector                                     |
|---|--|
| Vishay S.A.<br>Division SFERNICE<br>199, Boulevard de la<br>Madeleine<br>CS71159<br>F-06003 Nice Cedex 01<br>France | Mathilde FONTAINE<br>EMAIL: mathilde.fontaine@vishay.com |

# 5.3.1.2 Qualification

| Current Qualification<br>Certificate No. | In QML<br>since: | Type Designation  |
|--|------------------|---|
| 287H                                     |                  | Thin Film Technology for Chip, Wraparound, Single and Network<br>Resistors, Fixed, Based on Types P for Single Chip, PRA and CNW<br>for Resistor Networks |

#### APPLICABLE DOCUMENTS

ESCC Generic Specification No. 4001

ESCC Detail Specification Nos. 4001/023, 4001/025

Vishay S.A. Process Identification Document PID PID-TFD P PRA CNW

#### 5.3.1.3 List of Qualified Components

**NOTE:** the Established Reliability Level R is evaluated according to ESCC specification 26000.

Type PHR, Variants 01 to 08, 13 and 14 are qualified

Type PFRR, Variants 09 to 12 and 15 are qualified

Type PRAHR/CNWHR, Variants 01 to 42 are qualified

| Detail<br>Specification |           |  |
|-------------------------|-----------|--|
| 4001/023                | PHR       | High Stability and Precision Chip                                      |
| 4001/023                | PFRR      | High Stability and Precision Chip with Established Reliability Level R |
| 4001/025                | PRA/CNWHR | High Stability and Precision Surface Mount Array                       |





Lead material is E with either Type 2 or Type 4 finish. The terminal material and finish of some of these variants makes them unsuitable for solder assembly methods. They shall be assembled using glue or wire bond techniques. See Detail specifications.

Operating Temperature Range, (°C): -55 to +155

# TYPE PHR:

| Detail<br>Specification | Style | Critical R<br>(kΩ) | Rated Dissipation<br>(W) | Limiting Element<br>Voltage (V) | Type Variant |
|-------------------------|-------|--------------------|--------------------------|---------------------------------|--------------|
|                         | 0402  | 18                 | 0.050                    | 30                              | 13; 14       |
| 4001/023                | 0603  | 12.25              | 0.100                    | 35                              | 01; 05       |
|                         | 0805  | 45                 | 0.125                    | 75                              | 02; 06       |
|                         | 1206  | 40                 | 0.250                    | 100                             | 03; 07       |
|                         | 2010  | 45                 | 0.500                    | 150                             | 04; 08       |

| Variant | Style | Resistance | Range (Note 1)    | Tolerance (±%) (Note 2) | Temperature                        | Weight |
|---------|-------|------------|-------------------|-------------------------|------------------------------------|--------|
|         |       | Min (Ω)    | Max (MΩ)          |                         | Coefficient (10 <sup>-6</sup> /°C) | (g)    |
|         |       |            |                   |                         | (Note 2)                           |        |
| 01, 05  | 0603  | 10         | 0.200             | 0.01; 0.02; 0.05; 0.1   | ±5; ±10; ±25                       | 0.003  |
|         |       |            | (0.160 for TC"C") |                         |                                    |        |
| 02, 06  | 0805  | 10         | 0.250             | 0.01; 0.02; 0.05; 0.1   | ±5; ±10; ±25                       | 0.004  |
| 03, 07  | 1206  | 10         | 1.000             | 0.01; 0.02; 0.05; 0.1   | ±5; ±10; ±25                       | 0.01   |
| 04,08   | 2010  | 10         | 3.000             | 0.01; 0.02; 0.05; 0.1   | ±5; ±10; ±25                       | 0.03   |
| 13, 14  | 0402  | 10         | 0.100             | 0.01; 0.02; 0.05; 0.1   | ±5; ±10; ±25                       | 0.002  |
|         |       |            | (0.067 for TC"C") |                         |                                    |        |

# <u>NOTE 1:</u>

| Variant | Style | Critical        |
|---------|-------|-----------------|
|         |       | Resistance (KΩ) |
| 01 - 05 | 0603  | 12.25           |
| 02 - 06 | 0805  | 45              |
| 03 - 07 | 1206  | 40              |
| 04 - 08 | 2010  | 45              |
| 13 - 14 | 0402  | 18              |

#### NOTE 2:

| Resistance ( $\Omega$ ) Available Tolerances (±%) |                          | Series           |
|---|--------------------------|------------------|
| 10 ≤ R < 50                                       | 0.1                      |                  |
| 50 ≤ R < 100                                      | 0.05 and 0.1             | Any value in the |
| 100 ≤ R < 250                                     | 0.02; 0.05 and 0.1       | resistance range |
| R ≥ 250   | 0.01; 0.02; 0.05 and 0.1 |                  |





PAGE 36

| Resistance (Ω) | Temperature Coefficient<br>(ppm/ºC) | Series           |
|----------------|-------------------------------------|------------------|
| 10 ≤ R < 20    | E: 25 (-55°C; +155 °C)              |                  |
| 20 ≤ R < 50    | Y: 10 (-55°C; +155 °C)              | Any value in the |
| 20 ≤ R < 50    | Z: 5 (+22°C; +70 °C)                | resistance range |
| R ≥ 50         | C: 5 (-55°C; +155 °C)               |                  |

# **TYPE PFRR:**

| Detail<br>Specification | Style | Critical R<br>(kΩ) | Rated Dissipation<br>(W) | Limiting Element<br>Voltage (V) | Type Variant |
|-------------------------|-------|--------------------|--------------------------|---------------------------------|--------------|
| 4004/000                | 0402  | 32                 | 0.050                    | 40                              | 15           |
| 4001/023                | 0603  | 25                 | 0.100                    | 50                              | 09           |
|                         | 0805  | 80                 | 0.125                    | 100                             | 10           |
|                         | 1206  | 90                 | 0.250                    | 150                             | 11           |
|                         | 2010  | 80                 | 0.500                    | 200                             | 12           |

| Style                        | Resistance Range<br>(Ω) | Tolerance (±%) | Temperature Coefficient<br>TC(±10 <sup>-6</sup> /°C) |
|------------------------------|-------------------------|----------------|--|
| 0402; 0603; 0805; 1206; 2010 | From 100 to ≤ 100K      | 0.05; 0.1      | 10; 25   |
| 0603; 0805; 1206; 2010       | From 100 to ≤ 261K      | 0.05; 0.1      | 10; 25   |
| 0805; 1206; 2010             | From 261K to ≤ 301K     | 0.05; 0.1      | 10; 25   |
| 1206; 2010                   | From 301K to ≤ 1M       | 0.05; 0.1      | 10; 25   |
| 2010                         | From 1M to 3M01         | 0.05; 0.1      | 10; 25   |

# **TYPE PRAHR/CNWHR:**

| Detail<br>Specification | Style  | Critical R (K Ω) | Rated<br>Dissipation | Limiting Element<br>Voltage | Type<br>Same Ohmic | Variant<br>Different Ohmic |
|-------------------------|--------|------------------|----------------------|-----------------------------|--------------------|----------------------------|
|                         |        |                  | (W/resistor)         | U U                         | Values             | Values                     |
| 4001/025                | PRA100 | 12.25            | 0.100                | 35                          | 01 to 07           | 22 to 28                   |
|                         | PRA135 | 56.25            | 0.100                | 75                          | 08 to 14           | 29 to 35                   |
|                         | PRA182 | 100              | 0.100                | 100                         | 15 to 21           | 36 to 42                   |



**ISSUE 29** 

| Style                  | Resistance Range<br>(Ω) | Tolerance<br>(±%) |           | Temperature Coefficient<br>TC(±10-6 /°C) |          |
|------------------------|-------------------------|-------------------|-----------|--|----------|
|                        |                         | Absolute          | Relative  | Absolute                                 | Relative |
| PRA100; PRA135; PRA182 | From 100 to 200K        | 0.1; 0.5; 1       | 0.05; 0.1 | 10                                       | 3; 5     |
| PRA135; PRA182         | From 200K to 250K       | 0.1; 0.5; 1       | 0.05; 0.1 | 10                                       | 3; 5     |
| PRA182                 | From 250K to 1M         | 0.1; 0.5; 1       | 0.05; 0.1 | 10                                       | 3; 5     |

Number of Resistors per Array: 2 to 8

#### NOTES:

- 1. Note that gold finish variants are not intended for de-golding and tinning.
- The electrical ranges of these ESCC QML Qualified components variants are listed in the ESCC Detail Specifications and in the Qualified Part List (REP005) document available on the ESCIES website, https:// escies.org.

# 5.3.1.4 Technology Flow Abstract

### **GENERAL FEATURES**

The thin film technology for chip, fixed, wraparound, single and network resistors are designed on types based on P for single chip, PRA for 2 to 8 resistors of similar value and CNW for 2 to 8 resistors with at least two different values with the same form factor as PRA.

| Technology Flow | Scope  | Site  |
|-----------------|--|---|
| Design Centre   | Single resistor chips in 0402 0603, 0805,<br>1206 and 2010 formats<br>2 to 8 resistors of similar value in formats<br>0603, 0805 and 1206<br>2 to 8 resistors with at least 2 different values<br>with the same form factor, 0603,<br>0805 or 1206 | Vishay S.A.<br>Division SFERNICE<br>199, Boulevard de la<br>Madeleine<br>CS71159<br>F-06003 Nice Cedex 01<br>France |
| Fabrication     | Film deposition<br>Photolithography<br>Thermal treatment<br>Passivation<br>Thermal stabilization and control   | As above  |
| Assembly        | Laser trim Protective layer Termination and Test   | As above  |
| Test            | Chart F2, F3 and F4<br>Periodic Testing  | As above  |

#### **BASIC INFORMATION**

The technology consists of:

-Substrate: High purity alumina (99.5%)



- -Resistive Layer: Nickel chromium
- -Passivation Layer: Silicon Nitride
- -Protection: Epoxy and Silicone
- -Termination: Nickel barrier
- -Processes: Thin film deposition
- -Finish: SnPbAg or Au

Critical resistance by style:

- P 0402 FR:32 k
- P 0603 FR:25 k
- P 0603 HR:12.25 k
- P 0805 FR: 80k
- P 0805 HR: 45 k
- P 1206 FR: 90 k
- P 1206 HR: 40 k
- P 2010 FR: 80k
- P 2010 HR: 45 k
- PRA 100: 12.25 k
- PRA 135: 56.25 k
- PRA 182: 100 k

# COMPONENT TYPES

The available formats are defined in the variants table in the Detail Specifications. Variants with established reliability in accordance with Basic specification No. 26000 are designated with an "FR" suffix here for convenience. Variants 09, 10, 11 and 12 have established reliability level 'R' at 60% confidence level.

5.3.1.5 Technology Flow definition

# 1. Design

The design manuals covers the design rules and limits:

- HP-BE/001 (Maîtrise de la conception)
- HP-BE/004 (Données technologiques, Régles d'implementation, Performances)

Critical design characteristics:

- Minimum metal width: 10 μm
- Power dissipation lower than 250mW/mm2
- Current density lower than 7000 A/mm2
- Electrical field lower than 5V/ μm

# 2. Fabrication/Assembly

The manufacturing flows and procedures are described in section 4 of Vishay S.A.PID.

# 3. Test

Complete test sequence as detailed in ESCC Generic 4001 and the relevant Detail Specifications is conducted by Vishay S.A.



The deletion of the Third Harmonic Control requirement from ESCC Detail Specification No. 4001/023 for thin film wraparound technology is documented in reference report MAT/ 3HC/07.02 revision 3 dated 2007-06-20.

For variants with established reliability the efficiency of the Overload Test is increased with the implementation of a resistance change rejection criteria of 500 ppm and approved by TRB decisions on 2007-04-04.

# 4. Radiation Characteristics

The resistors covered in this technology domain is considered insensitive to radiation effects.





# 5.4 TRANSFORMERS (08)

# 5.4.1 Exxelia SAS: Custom magnetics: linear and toroidal technology

#### 5.4.1.1 Contact Information

| Address              | ESCC Chief Inspector    |
|----------------------|-------------------------|
| Exxelia SAS          | Mr. J. Pierre           |
| 16, Parc d'Activités | Tel: +33 3 82 59 13 33  |
| du Beau Vallon       |                         |
| F-57970 Illange      | EMAIL: info@exxelia.com |
| France               |                         |
|                      |                         |

# 5.4.1.2 Qualification

| Current<br>Qualification<br>Certificate<br>No. | In QML since: | Type Designation  |
|--|---------------|---|
| 356B   |               | Molded SMD custom magnetic components, linear (CCM)<br>winding technology |

#### APPLICABLE DOCUMENTS

ESCC Generic Specification No.3201

ESCC Detail Specification Nos. 3201/011 (CCM technology)

Exxelia. Process Identification Document PID 101 issue 5 rev 1 (CCM technology)

#### 5.4.1.3 List of Qualified Components

The component type variants and range of magnetics components applicable to the linear CCM technology are as follows:

| Variant<br>Number | Туре  | Design<br>Domain | Electrical<br>Characteristics | Total<br>Power Max<br>(W) | No. of<br>Terminals<br>(3) | Terminal<br>Finish (4) | Weight<br>Max (g) |
|-------------------|-------|------------------|-------------------------------|---------------------------|----------------------------|------------------------|-------------------|
| 01                | CCM4  | Note 1           | Note 2                        | ≤ 18                      | 12                         | Sn60Pb40               | 5.1               |
| 02                | CCM5  | Note 1           | Note 2                        | ≤ 40                      | 16                         | Sn60Pb40               | 7.4               |
| 03                | CCM6  | Note 1           | Note 2                        | ≤ 50                      | 16                         | Sn60Pb40               | 12.1              |
| 04                | CCM20 | Note 1           | Note 2                        | ≤ 120                     | 16                         | Sn60Pb40               | 21.4              |
| 05                | CCM25 | Note 1           | Note 2                        | ≤ 150                     | 20                         | Sn60Pb40               | 44.2              |

#### <u>NOTE 1</u>

The design domain for components produced in accordance with these specifications includes the following items:



- Development of customized electrical functions:
  - -Single or multi-coupled inductors
  - -Common mode chokes
  - -Power transformers (flyback, forward, push-pull, half/full bridge, specific architectures)
  - Signal transformers
  - Pulse transformers
  - - Current/voltage measurement transformers
  - -Specific magnetic functions within environment and thermal requirements

•Temperature range: -55°C +125°C

•Power, losses, and component heating:

- Maximum power depends on component heating. The heating is calculated from losses and thermal resistances for each Variant according to the electrical function. The thermal resistances are given in Maximum Rating.
- The maximum temperature rise at Tamb = +100°C is +25°C.
- Examples of maximum power per Variant are given above.

•Dielectric strength:

- Single insulation: 500Vrms
- Reinforced insulation for CCM technology: 1000Vrms

#### <u>NOTE 2</u>

All electrical characteristics applicable to a particular component design are specified in the document: Specific Component Design Sheet provided by the manufacturer.

#### 5.4.1.4 Technology Flow abstract

#### **GENERAL FEATURES**

The Technology Flow covers the design, manufacturing, assembly, in-process inspection, screening and testing of custom magnetic components at Exxelia, Illange, France.

These SMD inductors, chokes and transformers use linear winding (CCM technology) assembled on a lead frame and molded with epoxy resin.

#### **BASIC INFORMATION**

Leads: Brass with copper layer and SnPb finish

Molding: Epoxy resin

Wire: 180 °C magnet wire

Magnetic core: Chosen during design phase to meet customer requirements

Formats component types: See Details specifications 3201/011



#### 5.4.1.5 Technology Flow definition

#### 1. Design

The magnetic components are designed according to design rules and following a design process both described in the Exxelia document PID 101.

The design rules ensure maximum operating temperature below 125°C and dielectric strength

#### 2. Manufacturing process

The manufacturing process is described in the document PID 101 (CCM technology). Process summary:

- Linear winding for CCM technology
- High temperature soldering on the lead frame
- Transfer molding
- Magnetic core assembly for CCM technology
- Leads forming

#### 3. Control and testing

The control and test are performed in Exxelia Illange. They are performed according to the document Specific Component Design Sheet and the generic ESCC specification 3201 and the ESCC detail specification 3201/011

#### 4. Radiation characteristics

CCM magnetics components are not sensitive to radiations.

5.4.1.6 Manufacturing site

Exxelia 16 Parc d'Activités du Beau Vallon F57970 Illange France

#### 5.4.2 Flux A/S: Custom Magnetics (Inductors, Chokes and Transformers)

5.4.2.1 Contact Information

| Address                         | ESCC Chief Inspector   |
|---------------------------------|--|
| Industrivangen 5<br>4550 Asnaes | Mr. C. A. D. Winther<br>Tel: +45 5935 7713<br>EMAIL: caw@flux.dk |

#### 5.4.2.2 Qualification

| Current<br>Qualification<br>Certificate No. | In QML since: | Type Designation                                      |
|---|---------------|---|
| 364B  | March 2020    | Custom Magnetics (Inductors, Chokes and Transformers) |





# APPLICABLE DOCUMENTS

ESCC Generic Specification No.3201

ESCC Detail Specification No. 3201/013

Process Identification Document PID 088699015-9, ESCC DML 08699003, ESCC DPL 08699004

A public extract of the qualified domain and PID is available in Flux document 08699018.

#### 5.4.2.3 List of Qualified Components

The part number is 3201/01301F[12345678-#] and has been generated in accordance with ESCC 3201/013. Flux A/S component identification is as follows: 12345678-#-C

The component types and range of magnetic components applicable to the inductors and chokes technology are defined herein:

| Variant Number                             | Design<br>Domain | Electrical<br>Characteristics | Number of<br>Terminals | Finish | Weight |
|--|------------------|-------------------------------|------------------------|--------|--------|
| Based on core size and type of termination | Note 1           | Note 2                        | Note 3                 | Note 4 | Note 5 |
| 12345xxx                                   |                  |                               |                        |        |        |

The component types and range of magnetic components applicable to the transformers technology are defined herein:

| Variant Number                                | Design<br>Domain | Electrical<br>Characteristics | Number of<br>Terminals | Finish | Weight |
|---|------------------|-------------------------------|------------------------|--------|--------|
| Based on core size and type<br>of termination | Note 1           | Note 2                        | Note 3                 | Note 4 | Note 5 |
| 14345xxx                                      |                  |                               |                        |        |        |

The component types and range of magnetic components applicable to the data transmission (Chokes, Inductors, Transformers) technology are defined herein:

| Variant Number  | Design<br>Domain | Electrical<br>Characteristics | Number of<br>Terminals | Finish | Weight |
|---|------------------|-------------------------------|------------------------|--------|--------|
| Based on core size and type<br>of termination<br>15345xxx | Note 1           | Note 2                        | Note 3                 | Note 4 | Note 5 |

#### NOTE 1 - DOMAIN

The design domain for the components manufactured includes the following:

- Development of customized electrical functions:
  - Single or multi-coupled inductors



- Common mode chokes /Differential
- Power transformers (flyback, forward, push-pull, half/full bridge, specific architectures)
- Signal transformers
- Pulse transformers
- Current/voltage measurement transformers
- Specific magnetic functions within environment and thermal requirements
- Integrated Magnetics
- Spike Killer (high frequency filter)
- High Frequency
- High Voltage
- Temperature Range -55°C to +130°C, depending on temperature class
- Maximum Power See Note 2
- Temperature rise See Note 2
- Dielectric Strength See Note 2

The multi-element assemblies featuring multiple transformers/inductors assembled on substrate, that Flux are capable of manufacturing, are not included into ESCC QML domain.

# **NOTE 2 - ELECTRICAL CHARACTERISTICS**

All electrical characteristics to a particular design are specified in the magnetics sheet, which is either produced or verified by the manufacturer.

The maximum ratings shall not be exceeded at any time during use or storage. Maximum ratings shall only be exceeded during testing to the extent specified in this specification and when stipulated in Test Methods and Procedures of the ESCC Generic Specification.

| Characteristics                    | Symbols          | Maximum Ratings<br>(Note 1)           | Units | Remarks          |
|------------------------------------|------------------|---------------------------------------|-------|------------------|
| Power                              | Р                | See Magnetic Sheet                    | W     | Upto 5 kW        |
| Rated DC Current                   | I <sub>R</sub>   | See Magnetic Sheet                    | mA    | Upto 62.5A       |
| Dielectric Withstanding<br>Voltage | DWV              | See Magnetic Sheet                    | Vrms  |                  |
| Operating Frequency                | f                | See Magnetic Sheet                    | Hz    | Upto 10 Mhz      |
| Operating Temperature<br>Range     | T <sub>op</sub>  | See Magnetic Sheet<br>(-55 to +130°C) | °C    | T <sub>amb</sub> |
| Storage Temperature<br>Range       | T <sub>stg</sub> | See Magnetic Sheet<br>(-55 to +155°C) | °C    |                  |
| Soldering Temperature              | T <sub>sol</sub> | +260 for SnPb<br>+300 for SnAg        | °C    | Note 2           |

NOTES:

- 1. This Maximum Rating for a particular component will be specified in the Magnetic Sheet for that component
- 2. The maximum operating temperature shall not exceed the derated material temperature-(Temperature rise+Hotspot)
- 3. The maximum storage temperature shall not exceed the derated material temperature



4. Unless otherwise specified in the applicable Magnetic Duration 5 seconds maximum, the same terminal shall not be resoldered until 3 minutes have elapsed.

#### NOTE 3 – NUMBER OF TERMINALS

The number of terminals or leads are specified in the magnetics sheet, which is either produced or verified by the manufacturer.

#### **NOTE 4 – MATERIAL AND FINISHES**

The minimum wire size shall be Ø0.10mm

The materials and finishes including case and terminals for a particular component will be specified in the Magnetic Sheet for that component. All materials shall meet the requirements of ECSS-Q-ST-70-71 and are detailed in FT08699004.

#### NOTE 5 - WEIGHT AND PHYSICAL DIMENSIONS

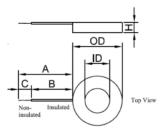
The weight and physical dimension are specified in the magnetics sheet.

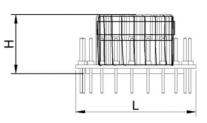
The overall dimensions for the range of cores used in components, depending on the design type used, are as follows:

 For toroid based designs: effective core (The minimum physical area which the total flux runs through the core) area of 2mm2 to 199mm2; see examples below:

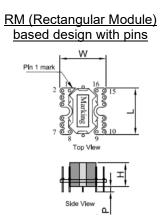
Toroid with flying leads



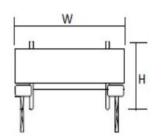




- For coil former based designs: effective core area 2.66mm2 to 146mm2; see examples below:

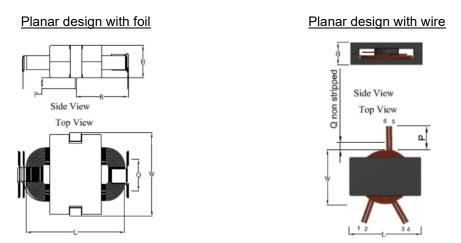






- For custom designs: effective core area 0.14mm2 to 484mm2; see examples below:





Unless otherwise specified in the applicable Magnetic Sheet and where applicable, terminals shall be colour coded.

5.4.2.4 Technology Flow abstract

# **GENERAL FEATURES**

The Technology Flow covers the design, manufacturing, assembly, in-process inspection, screening and testing of custom magnetic components at Flux A/S, Denmark.

# BASIC INFORMATION

Leads: As per ECSS-Q-ST-70-08

Molding: As specified and listed in DML

Wire: As specified and listed in DML

Magnetic core: Chosen during design phase to meet customer requirements and listed in DML.

Formats component types: See Detail specification 3201/013 and magnetic sheets.

# 5.4.2.5 Technology Flow definition

#### 1. Design

The magnetic components are designed according to design rules and following a design process described in the PID FT088699015. The design rules ensures operation within specified temperature class, see magnetic sheet.

During the electrical design the specified voltage, current, frequency, and power is ensured the design is within the domain.

With the electrical design in place the core and mechanical design is checked against the physical domain constraints.



Finally the materials and production processes are compared to the ESCC DML and DPL to ensure the complete design is within the domain.

Electrical rule set:

| Parameter                        | Inductor   | Transformer |
|----------------------------------|------------|-------------|
| Output Power [W]                 | 0≤P≤2,5kW  | 0≤P≤ 5 kW   |
| Voltage [V]                      | 0≤V≤110V   | 0≤V≤3kV     |
| Current [A]                      | 0≤I≤35A    | 0≤I≤62.5 A  |
| Dielectrical Breakdown           | 950≤V≤8kV  | 950≤V≤8kV   |
| Temperature [ºC]                 | -55≤T≤155  | -55≤T≤155   |
| Dimensions[mm³] (Core<br>Volume) | 1≤V≤164000 | 2≤∨≤234000  |

**NOTE:** Voltage and current values are absolute values.

# 2. Manufacturing process

The manufacturing process is described in the PID FT088699015 and DPL FT08699004. Materials and Processes are selected from Flux's ESCC DML and DPL respectively.

#### 3. Control and testing

Control and testing are performed at Flux A/S.

They are performed according to the part specific magnetic sheet and the generic ESCC specification 3201 and the ESCC detail specification 3201/013

#### 4. Radiation characteristics

These magnetic components are not sensitive to radiation.

#### 5.4.2.6 Manufacturing site

Flux A/S, Industrivangen 5, 4550 Asnaes, Denmark